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PATENT, TRADEMARK
AND COPYRIGHT

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December 16, 2003

Office of Initial Patent Examination's Filing Receipt Corrections
Fax No. 703- 746-9195

Re: REQUEST FOR CORRECTED FILING RECEIPT

Inventor(s) : Ki-Cheol Lee et al.
Assignor(s) : Samsung Electronics Co., Ltd.
Title : WAVELENGTH PATH
MONITORING/CORRECTING APPARATUS
IN TRANSPARENT OPTICAL CROSS-
CONNECT AND METHOD THEREOF
Serial No. : 10/635,943
Filed : August 7, 2003
Docket No. : 5000-1-416

Dear Sir:

Applicant hereby request that a corrected Formal Filing Receipt be issued to correct the applicant's Foreign Application Date.

Please correct applicant's Foreign Application Date from [05/02/2003] to

--02/05/2003--

as requested in our December 4, 2003 REQUEST FOR CORRECTED FILING RECEIPT, copy enclosed.

A copy of the filing receipt with the requested correction is enclosed.

Applicants accordingly request that the records of the U.S. Patent and Trademark Office be corrected to reflect the correct Foreign Application Date and that a corrected Formal Filing Receipt be issued.

Respectfully submitted,


Steve Cha

Attorney for Applicant(s)

Registration No. 44,069

SC/lc

Enclosure



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov

| APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS |
|------------|---------------------------|----------|---------------|-----------------|----------|----------|----------|
| 10/635,943 | 08/07/2003 | 2874 | 834 | 5000-1-416 | 9 | 16 | 4 |

33942
 CHA & REITER, LLC
 210 ROUTE 4 EAST
 PARAMUS, NJ 07652

CONFIRMATION NO. 1229

CORRECTED FILING RECEIPT

OC000000011470665

Date Mailed: 12/11/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Ki-Cheol Lee, Suwon-shi, KOREA, REPUBLIC OF;
 Yun-Je Oh, Yongin-shi, KOREA, REPUBLIC OF;
 Jong-Kwon Kim, Taejonkwangyok-shi, KOREA, REPUBLIC OF;

Domestic Priority data as claimed by applicant

Foreign Applications

REPUBLIC OF KOREA 2003-7205[05/02/2003] --02/05/2003--

If Required, Foreign Filing License Granted: 11/07/2003

Projected Publication Date: 11/04/2004

Non-Publication Request: No

Early Publication Request: No

Title

Wavelength path monitoring/correcting apparatus in transparent optical cross-connect and method thereof

Preliminary Class
385

**LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

GRANTED

The applicant has been granted a license under 35 U.S.C. 184, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" followed by a date appears on this form. Such licenses are issued in all applications where the conditions for issuance of a license have been met, regardless of whether or not a license may be required as set forth in 37 CFR 5.15. The scope and limitations of this license are set forth in 37 CFR 5.15(a) unless an earlier license has been issued under 37 CFR 5.15(b). The license is subject to revocation upon written notification. The date indicated is the effective date of the license, unless an earlier license of similar scope has been granted under 37 CFR 5.13 or 5.14.

This license is to be retained by the licensee and may be used at any time on or after the effective date thereof unless it is revoked. This license is automatically transferred to any related applications(s) filed under 37 CFR 1.53(d). This license is not retroactive.

The grant of a license does not in any way lessen the responsibility of a licensee for the security of the subject matter as imposed by any Government contract or the provisions of existing laws relating to espionage and the national security or the export of technical data. Licensees should apprise themselves of current regulations especially with respect to certain countries, of other agencies, particularly the Office of Defense Trade Controls, Department of State (with respect to Arms, Munitions and Implements of War (22 CFR 121-128)); the Office of Export Administration, Department of Commerce (15 CFR 370.10 (j)); the Office of Foreign Assets Control, Department of Treasury (31 CFR Parts 500+) and the Department of Energy.

NOT GRANTED

No license under 35 U.S.C. 184 has been granted at this time, if the phrase "IF REQUIRED, FOREIGN FILING LICENSE GRANTED" DOES NOT appear on this form. Applicant may still petition for a license under 37 CFR 5.12, if a license is desired before the expiration of 6 months from the filing date of the application. If 6 months has lapsed from the filing date of this application and the licensee has not received any indication of a secrecy order under 35 U.S.C. 181, the licensee may foreign file the application pursuant to 37 CFR 5.15(b).

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December 4, 2003

Office of Initial Patent Examination's Filing Receipt Corrections
Fax No. 703- 746-9195

Re: REQUEST FOR CORRECTED FILING RECEIPT

Inventor(s) : Ki-Cheol Lee et al.
Assignor(s) : Samsung Electronics Co., Ltd.
Title : WAVELENGTH PATH MONITORING/CORRECTING APPARATUS IN
TRANSPARENT OPTICAL CROSS-CONNECT AND METHOD THEREOF
Serial No. : 10/635,943
Filed : August 7, 2003
Docket No. : 5000-1-416

Dear Sir:

Applicant hereby request that a corrected Formal Filing Receipt be issued to correct the three applicants' country and the date claimed for prior foreign applications.

Please correct applicants' country from (TAIWAN) to

-- REPUBLIC OF KOREA --

as it appears on the Declaration, copy enclosed.

Please correct the prior filing date for Foreign Application from (05/02/2003) to

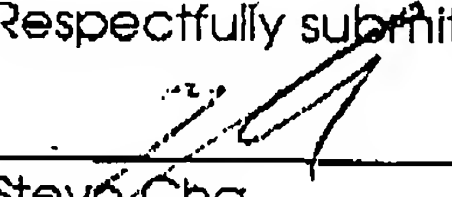
--02/05/2003--

as shown on Petition for Grant of Priority, copy enclosed.

A copy of the filing receipt with the requested corrections is enclosed.

Applicants accordingly request that the records of the U.S. Patent and Trademark Office be corrected to reflect the Applicants' correct country, correct filing date for Foreign Application and that a corrected Formal Filing Receipt be issued.

Respectfully submitted,


Steve Cha
Attorney for Applicant(s)
Registration No. 44,069

SC/lc
Enclosures

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS : Ki-Cheol LEE et al.
SERIAL NO. : Not Yet Assigned
FILED : August 7, 2003
FOR : WAVELENGTH PATH MONITORING/CORRECTING
APPARATUS IN TRANSPARENT OPTICAL CROSS-
CONNECT AND METHOD THEREOF

PETITION FOR GRANT OF PRIORITY UNDER 35 USC 119

MAIL STOP PATENT APPLICATION
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA. 22313-1450

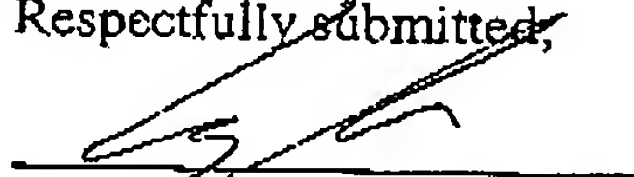
Dear Sir:

Applicant hereby petitions for grant of priority of the present Application on the basis of the following prior filed foreign Application:

| <u>COUNTRY</u> | <u>SERIAL NO.</u> | <u>FILING DATE</u> |
|-------------------|-------------------|--------------------|
| Republic of Korea | 2003-7205 | February 5, 2003 |

To perfect Applicant's claim to priority, a certified copy of the above listed prior filed Application is enclosed. Acknowledgment of Applicant's perfection of claim to priority is accordingly requested.

Respectfully submitted,


Steve S. Cha
Attorney for Applicant
Registration No. 44,069

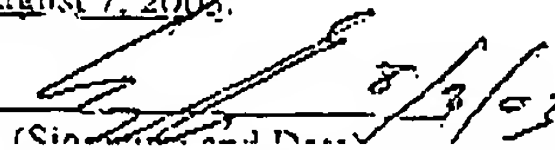
CHA & REITER
411 Hackensack Ave, 9th floor
Hackensack, NJ 07601
(201)518-5518

Date: August 7, 2003

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to MAIL STOP PATENT APPLICATION, COMMISSIONER FOR PATENTS, P. O. BOX 1450, ALEXANDRIA, VA. 22313-1450 on August 7, 2003.

Steve S. Cha, Reg. No. 44,069
Name of Registered Rep.)


(Signed and dated)